

| Search Notes  | Application/Control No. | Applicant(s)/Patent under Reexamination | |
|---|-------------------------|---|--|
| | 10/560,729 | NISSEN, PER | |
| | Examiner | Art Unit | |
| | Louis K. Huynh | 3721 | |

| INTERFERENCE SEARCHED | | | |
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| Class | Subclass | Date | Examiner |
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